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**FACSIMILE COVER SHEET**

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| To Examiner:      | Hsien Ming Lee         | Total Pages Sent:       | 14              |
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| Facsimile Number: | 703-872-9318           | Transmission Date:      | August 25, 2003 |

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

|             |                 |             |               |
|-------------|-----------------|-------------|---------------|
| Applicant:  | Fang            | Docket No.: | 01-P-14755 US |
| Serial No:  | 09/941,963      | Art Unit:   | 2823          |
| Date Filed: | August 28, 2001 |             |               |

**TITLE:** Method of Cleaning an Inter-Level Dielectric Interconnect

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I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9318 on the date shown above:

- Amendment (13 pages)

Respectfully submitted,



Natalie Swider  
Legal Assistant

**Confirmation Respectfully Requested**

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Fang Art Unit: 2823  
Serial No.: 09/941,963 Examiner: Hsien Ming Lee  
Filed: August 28, 2001 Docket No.: 01-P-14755 US  
For: Method of Cleaning an Inter-Level Dielectric Interconnect

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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## AMENDMENT

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated June 4, 2003. Applicant respectfully requests reconsideration of the claims in view of the following amendments and remarks, which are believed to be a full and complete response to the Office Action.

01-P-14755 US

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